

■ With ULVAC Group's wide synthetic power

Supporting customers by sales of related systems, samplings of leading-edge technological fields and requested evaluations

1. UHV, XHV available process

Film preparation at ultra-clean space

Measurement, evaluation under XHV atmosphere

2. Nano-technology

Materialization of high-magnified, high-accuracy measurement and evaluation

Able to prepare and measure the fine structure

3. Thermal analysis

Available for development of next-generation materials

Experimental System for R&D Support



Equipment Name		Helicon Sputtering	Epitaxial	Etching	Ion Implantation	Carbon Nano-tube	Lamp Heating	Acter Pump
Model		MPS-HC	MBC	CE-300 I CE-300R	UP-150	CN-CVD	VHC RTA	PST
Application	Semiconductor Devices		○	○	○		○	
	Magnetic Storage	○		○	○			
	Display			○	○	○		
	Energy							○
	High-functional materials	○	○		○	○		